

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**  
( Not for submission under 37 CFR 1.99)

Application Number	10764345
Filing Date	2004-01-23
First Named Inventor	Tie Liu
Art Unit	3685
Examiner Name	Dante Ravetti
Attorney Docket Number	MS1-1811US

**U.S.PATENTS**

Examiner Initial*	Cite No	Patent Number	Kind Code <sup>1</sup>	Issue Date	Name of Patentee or Applicant of cited Document	Pages,Columns,Lines where Relevant Passages or Relevant Figures Appear
	1	7007166		2006-02-28	Moskowitz, ; et al.	
	2	7234640		2007-06-26	Pentel	

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**U.S.PATENT APPLICATION PUBLICATIONS**

Examiner Initial*	Cite No	Publication Number	Kind Code <sup>1</sup>	Publication Date	Name of Patentee or Applicant of cited Document	Pages,Columns,Lines where Relevant Passages or Relevant Figures Appear
	1	20050163313	A1	2005-07-28	Maitland, Roger; et al.	
	2	20060274114	A1	2006-12-07	Silverbrook; Kia; et al.	
	3	20070053325	A1	2007-03-08	Shin; Sung-Hyuk; et al.	

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**FOREIGN PATENT DOCUMENTS**

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	1	2000243067	JP	A1	2000-09-08	SONY CORP		<input type="checkbox"/>
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#### NON-PATENT LITERATURE DOCUMENTS

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	1	Liu et al., "A SVD-Based Watermarking Scheme for Protecting Rightful Ownership", IEEE Transaction on Multimedia, Vol. 4, Issue 1, March 2002, pp. 121-128.	<input type="checkbox"/>

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